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Technology and Culture (ISSN 0040-165X) is published quarterly, January, April, July, and October, by The University of Chicago Press. Subscriptions: institutions, 1 year \$35.00, 2 years \$63.00; individuals, 1 year \$22.50, 2 years \$40.50. Student subscription rate (U.S.A.): 1 year \$18.00 (letter from professor must accompany subscription). Single copy rates: institutions \$8.50; individuals \$6.00. Back issues are available from 1966 (vol. 7). The subscription rate includes membership in the Society for the History of Technology. Checks should be made payable to TECHNOLOGY AND CULTURE, The University of Chicago Press, 5801 Ellis Avenue, Chicago, Illinois 60637; all business correspondence should be sent to that office. All changes of address must include the old as well as the new address. Postmaster: Send address changes to *Technology and Culture*, 5801 Ellis Avenue, Chicago, Illinois 60637.

Volumes 1 through 6 available from Kraus Reprints, Route 100, Millwood, New York 10546.

Volumes available in microfilm from University Microfilms, 300 North Zeeb Road, Ann Arbor, Michigan 48106; in microfiche from Johnson Associates, P.O. Box 1017, Greenwich, Connecticut 06830, and J. S. Canner & Co., 49-65 Lansdowne Street, Boston, Massachusetts 02215.

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Published by The University of Chicago Press, Chicago, Illinois 60637; The University of Chicago Press Ltd., London W.C. 1. Second-class postage paid at Chicago, Illinois.

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